

Search Notes				Application/Control No.	Applicant(s)/Patent under Reexamination	
				10/657,162	FUJITA ET AL.	
				Examiner	Art Unit	
				Sean Reilly	2153	
SEARCHED				SEARCH NOTES (INCLUDING SEARCH STRATEGY)		
Class	Subclass	Date	Examiner		DATE	EXMR
709	203, 223-226	12/14/2005	SR	Inventor and Assignee Double Patenting search	8/9/2005	SR
711	170-173	12/14/2005	SR	Consulted w/ Examiner Edelman	8/9/2005	SR
709	213-214	10/4/06	SR	Consulted w/ Examiner Bragdon Class 711.	8/9/2005	SR
				Consulted w/ Steve Elmore Class 711	12/15/2005	SR
				NPL search of IEEE, ACM, and citeseer.com databases for storage management systems	12/14/2005	SR
				Consulted w/ Examiner Dinh	10/4/06	SR
				Updated Class Search	3/7/07	SR
				Consulted w/ SPE Vaughan	3/19/07	SR
				Allowable Subject matter.	And 10/4/06	SR
INTERFERENCE SEARCHED						
Class	Subclass	Date	Examiner			
709	223	3/7/07	SR			